

Form PTO-1449 U.S. Department of Commerce  
(Rev. 8-83) Patent and Trademark Office

# INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty. Docket No.: 756-1914

Serial No. 09/235,770

Applicant: Shunpei YAMAZAKI, et al.

Filing Date: January 25,  
1999

Group: 2813

## U.S. PATENT DOCUMENTS

Examiner Initial	Patent Number	Issue Date	Patentee	Class	Sub-class	Filing Date (if approp.)
<i>Sub</i>	4,455,737	06/26/84	Godejahn, Jr.			
<i>Sub</i>	4,646,426	03/03/87	Sasaki			
<i>Sub</i>	4,769,338	09/06/88	Ovshinsky et al.			
<i>Sub</i>	4,868,137	09/19/89	Kubota			
<i>Sub</i>	4,900,695	02/13/90	Takahashi et al.			
<i>Sub</i>	5,177,548	01/05/93	Nakamura et al.			
<i>Sub</i>	4,015,781	04/05/77	Beck			
<i>Sub</i>	5,468,987	11/21/95	Yamazaki et al.			
<i>Sub</i>	5,474,945	12/12/95	Yamazaki et al.			
<i>Sub</i>	5,495,121	02/27/96	Yamazaki et al.			
<i>Sub</i>	5,592,008	01/07/97	Yamazaki et al.			

## FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub-class	Translation Yes No
0 225 426	06/16/87	EPO			Full
0 301 463	02/01/89	EPO			Full
01-089464	04/03/89	Japan			Abstract
01-123234	05/22/89	Japan			Abstract
01-183845	07/21/89	Japan			Abstract

## OTHER DOCUMENTS (Including Author, Title, Relevant Pages, Date, Place of Publication)

<i>Sub</i>	Stanley Wolf, Ph.D., et al. "SILICON PROCESSING FOR THE VLSI ERA," Process Technology, Vol. I, pp. 151-157, Lattice Press, Sunset Beach, California.
<i>Sub</i>	Stanley Wolf, Ph.D., et al. "SILICON PROCESSING FOR THE VLSI ERA," Process Technology, Vol. II, pp. 66-72, Lattice Press, Sunset Beach, California.

Examiner: *Mauro Schillinger*

Date Considered: *8/28/00*

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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## U.S. PATENT DOCUMENTS

Examiner Initial	Patent Number	Issue Date	Patentee	Class	Sub-class	Filing Date (if approp.)
<i>LS</i>	5,596,214	01/21/97	Endo			
<i>LS</i>	5,879,969	03/09/99	Yamazaki et al.			

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub-class	Translation	
						Yes	No
<i>LS</i>	1-183853	07/21/89	Japan			Abstract	
<i>LS</i>	01-255831	10/12/89	Japan			Abstract	
<i>LS</i>	02-306664	12/20/90	Japan			Abstract	
<i>LS</i>	03-024735	02/01/91	Japan			Abstract	
<i>LS</i>	58-100461	06/15/83	Japan			Abstract	

## OTHER DOCUMENTS (Including Author, Title, Relevant Pages, Date, Place of Publication)


Examiner: *Laure Schilling*Date Considered: *8/30/00*

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**U.S. PATENT DOCUMENTS**

[illegible]

## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Sub-class	Translation	
							Yes	No
Sub sub sub sub sub		61-241976	10/28/86	Japan			Abstract	
		62-005662	01/12/87	Japan			Abstract	
		62-8573	01/16/87	Japan			Abstract	
		62-073658	04/04/87	Japan			Abstract	
		62-073660	04/04/87	Japan			Abstract	

**OTHER DOCUMENTS** (Including Author, Title, Relevant Pages, Date, Place of Publication)

[illegible]

Examiner:

Date Considered: 8/30/00

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